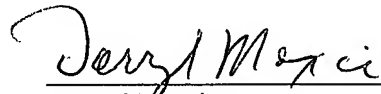


U.S.S.N. No. 10/074,258  
Q67115

**REMARKS**

Entry and consideration of this Amendment are respectfully requested.

Respectfully submitted,

  
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APPENDIX

VERSION WITH MARKINGS TO SHOW CHANGES MADE

IN THE SPECIFICATION:

The specification is changed as follows:

Page 2, first full paragraph:

A conventional optical modeling device used for such an optical modeling system is divided into a laser plotter type optical modeling device using a laser plotter for scanning and a movable mirror type modeling device using a movable mirror for scanning. Both types of the optical modeling devices can be referred to an issue titled, Maruya, Yoji. 1992. Hikari zokei shisutemu no kiso, genjou, mondaiten. (Foundation, status quo, and issues in optical molding systems technology.) Kata Gijutsu (Die and Mold Technology) 7, no. 10:18-23. ~~“foundation, status quo, issues, and molding technology of an optical modeling system” (published by Yoji Maruya: volume 7, No. 10, pp 18 to 23, 1992).~~